



Inventor: NIISOE
Docket No.: 10873.1388US01
Title: METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE
Serial No.: 10/750,359
Sheet 1 of 14

FIG. 1A

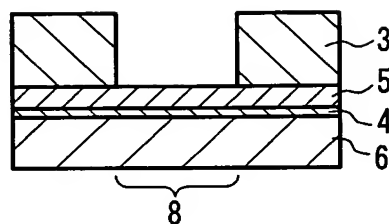
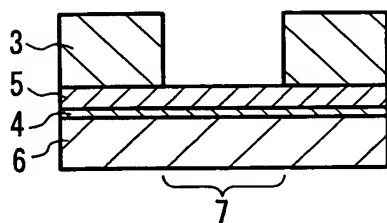


FIG. 1B

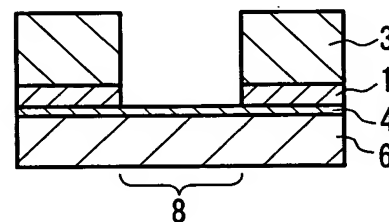
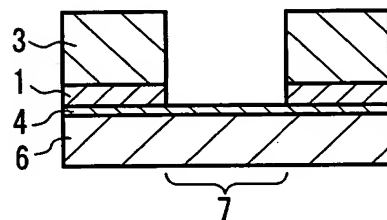


FIG. 1C

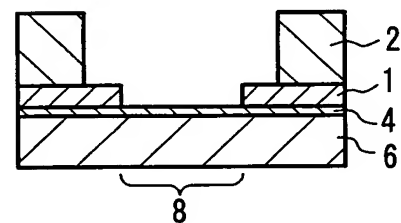
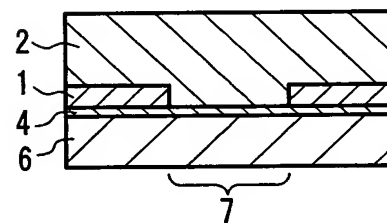


FIG. 1D

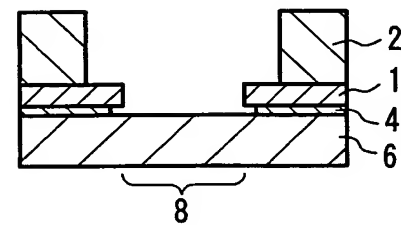
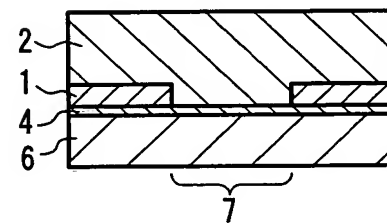


FIG. 2A

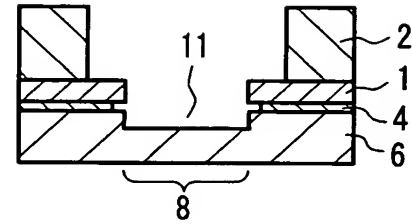
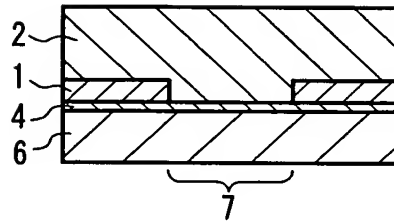


FIG. 2B

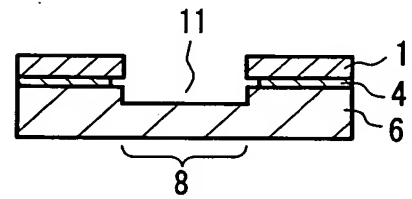
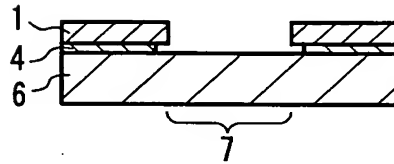


FIG. 2C

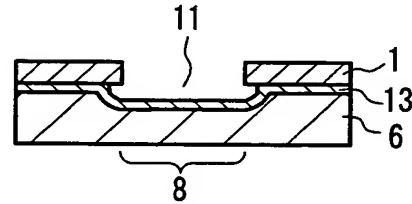
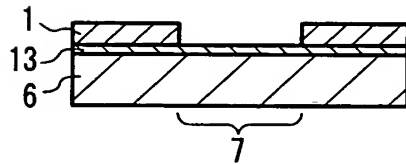


FIG. 2D

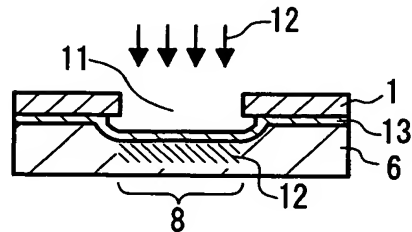
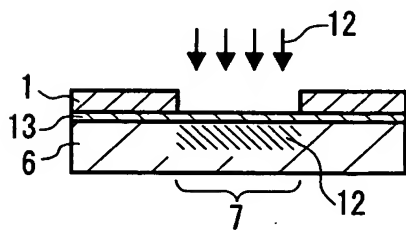
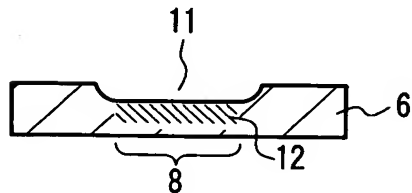
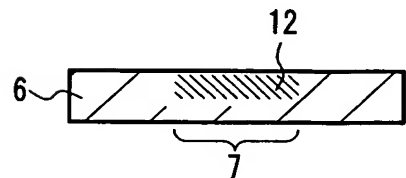


FIG. 2E



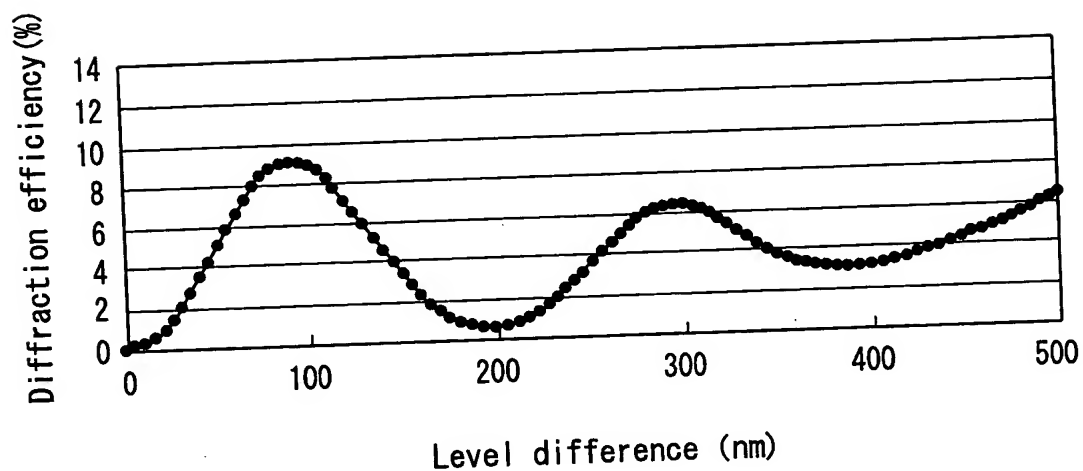


FIG. 3

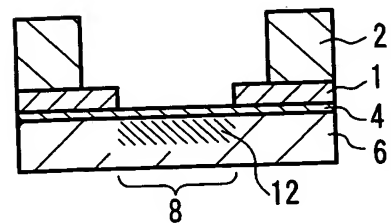
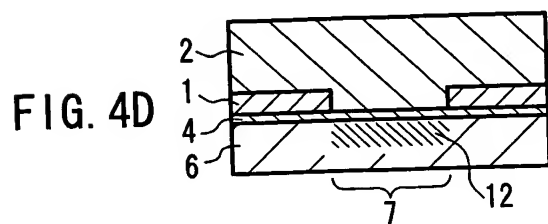
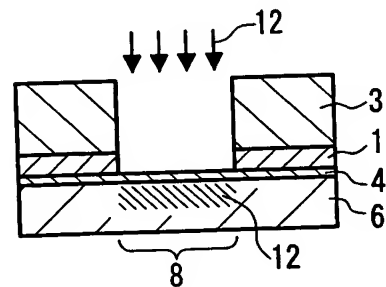
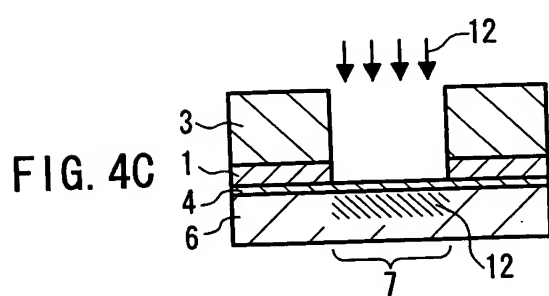
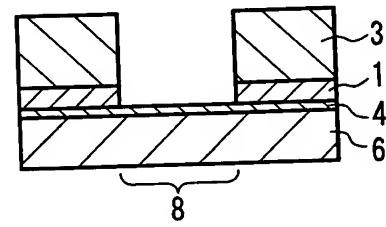
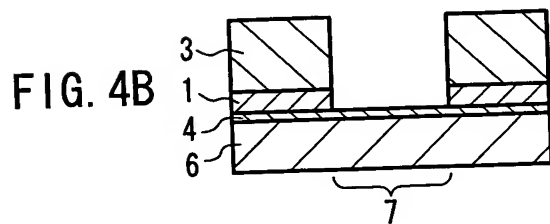
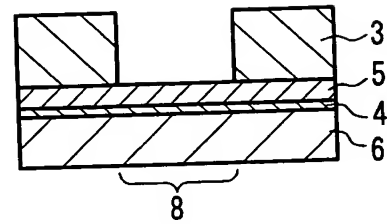
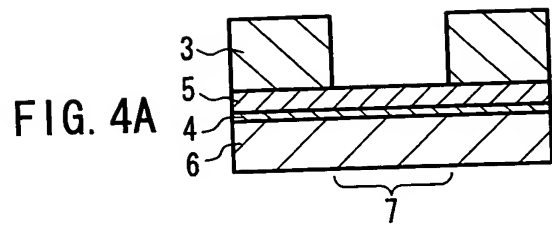


FIG. 5A

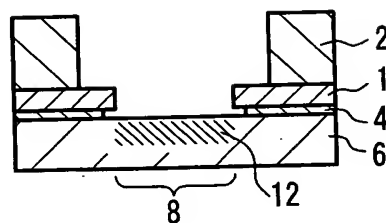
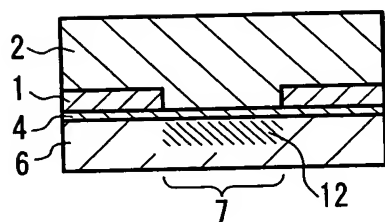


FIG. 5B

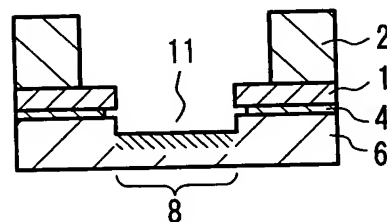
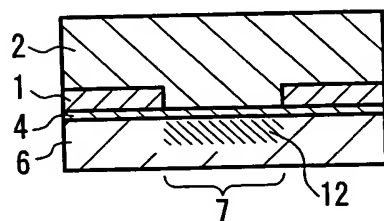


FIG. 5C

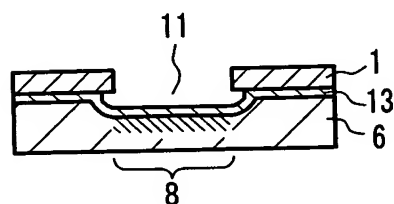
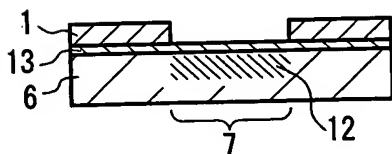


FIG. 5D

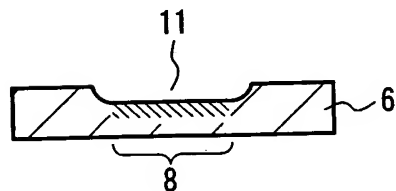
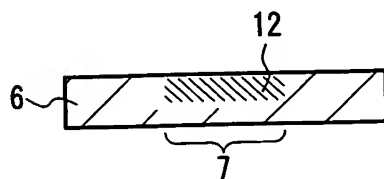


FIG. 6A

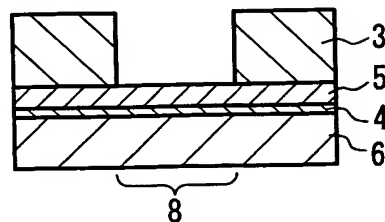
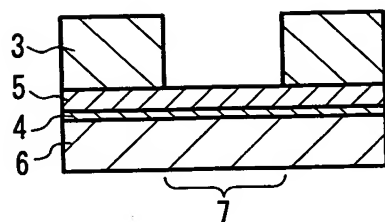


FIG. 6B

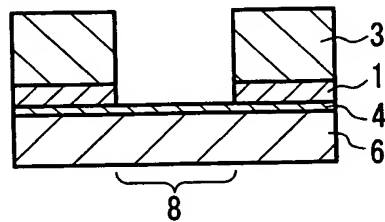
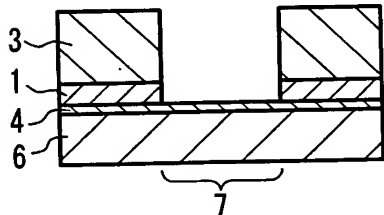


FIG. 6C

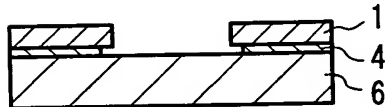
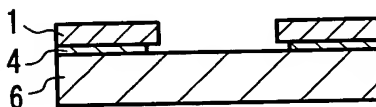


FIG. 6D

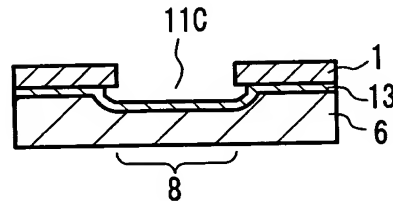
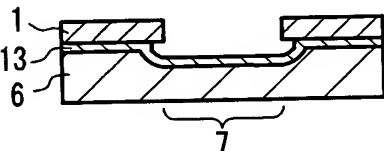


FIG. 6E

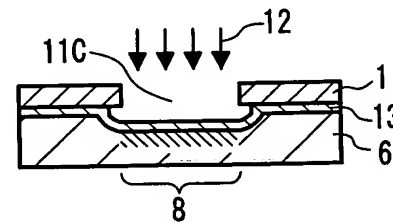
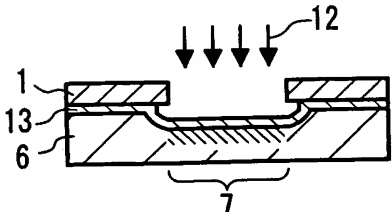
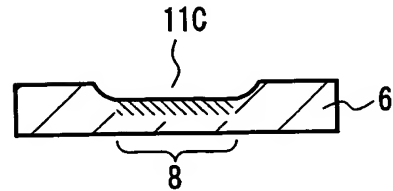
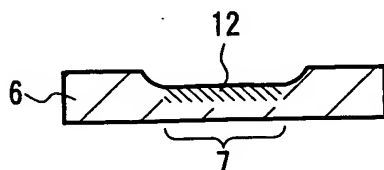


FIG. 6F



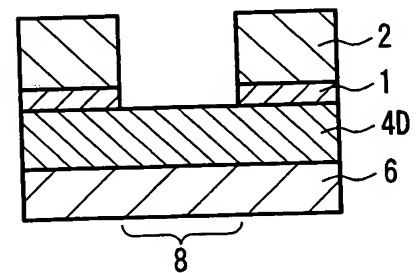
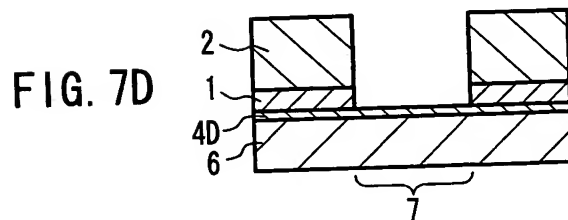
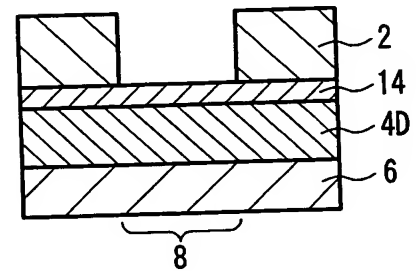
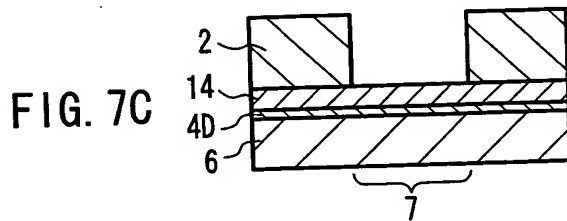
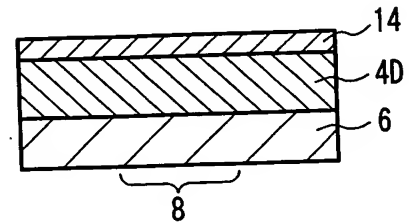
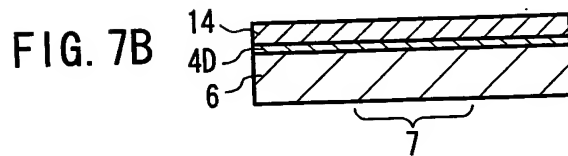
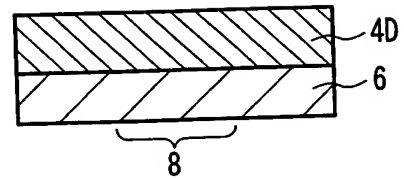
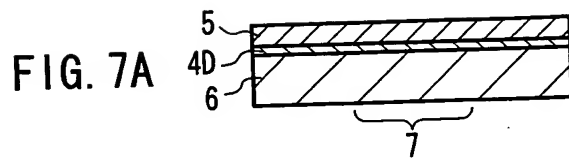


FIG. 8A

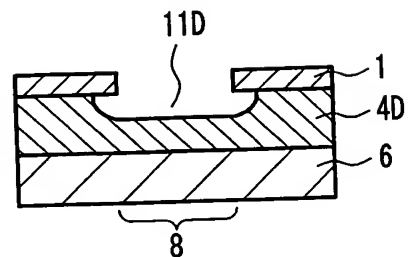
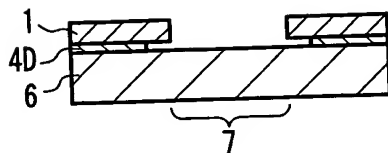


FIG. 8B

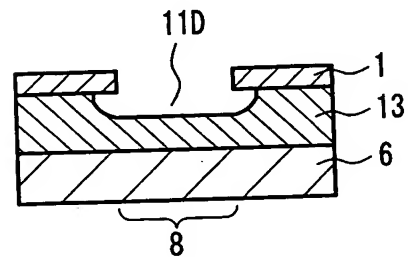
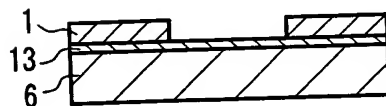


FIG. 8C

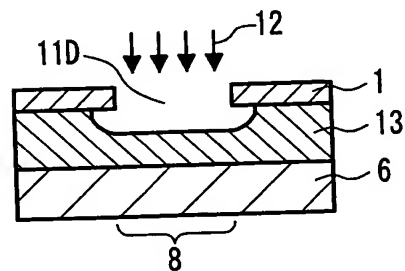
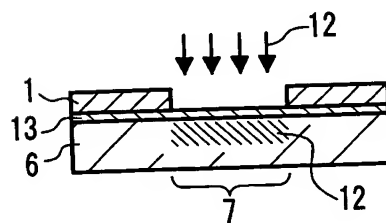


FIG. 8D

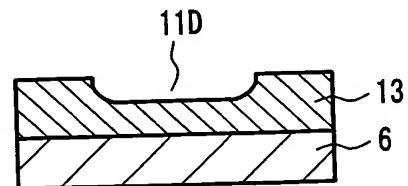
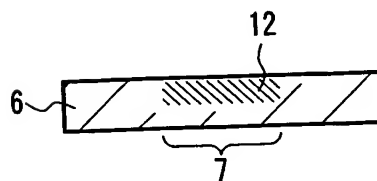


FIG. 9A

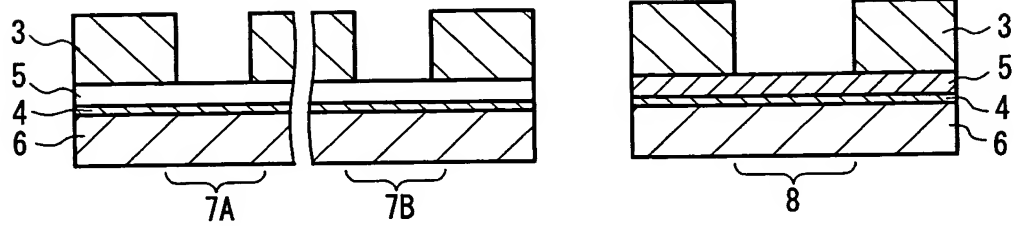


FIG. 9B

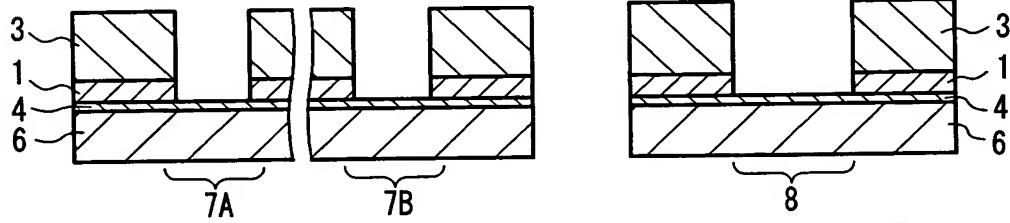


FIG. 9C

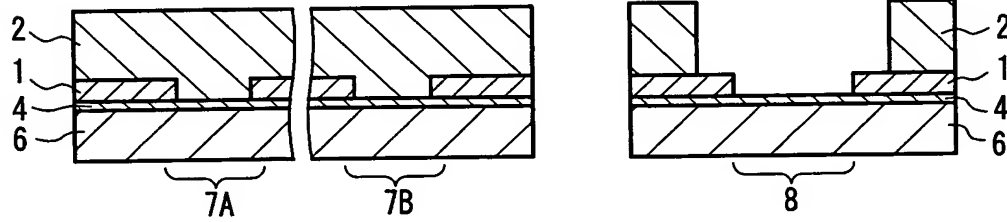


FIG. 9D

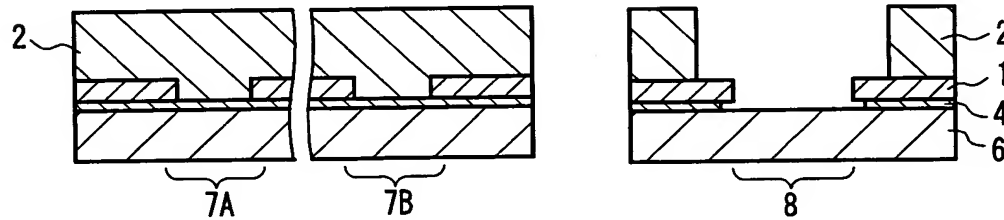


FIG. 9E

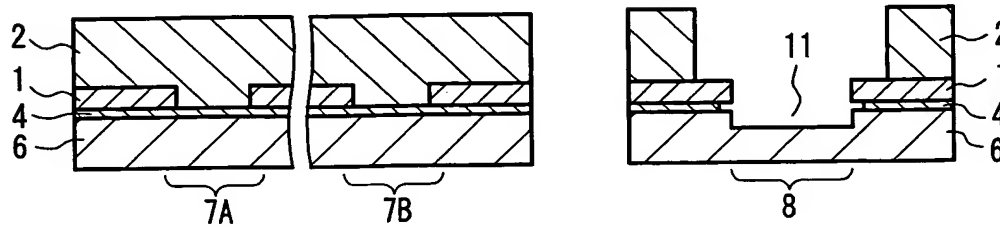


FIG. 10A

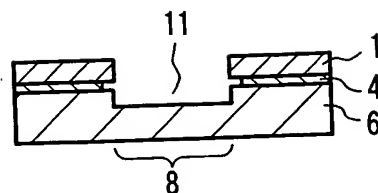
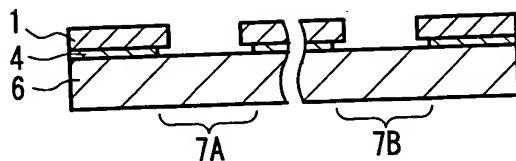


FIG. 10B

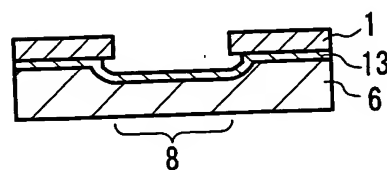
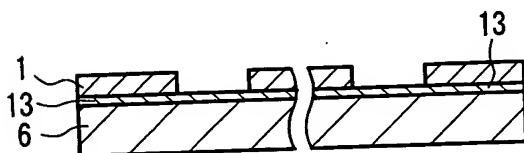


FIG. 10C

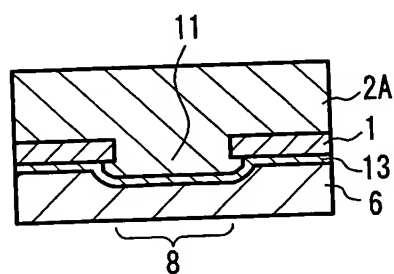
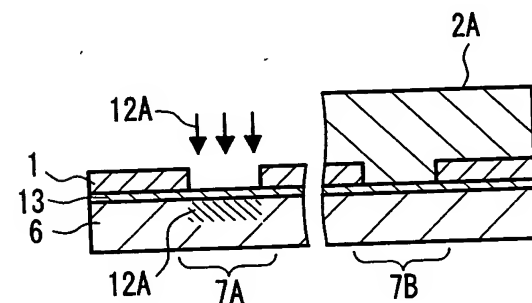


FIG. 10D

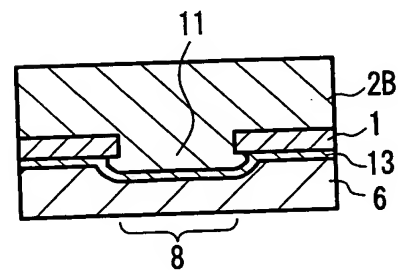
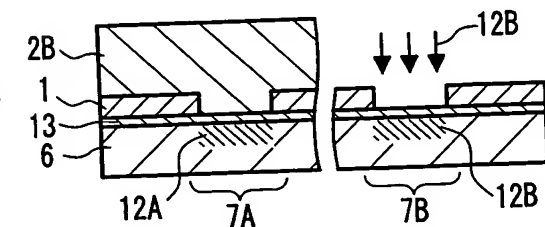


FIG. 10E

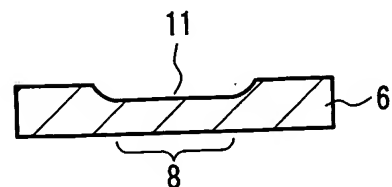


FIG. 11A
PRIOR ART

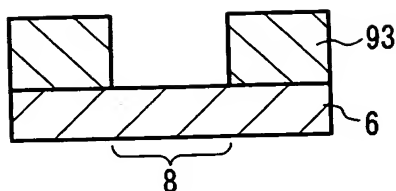
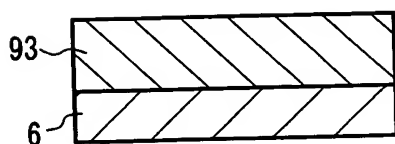


FIG. 11B
PRIOR ART

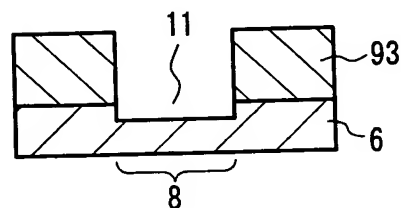
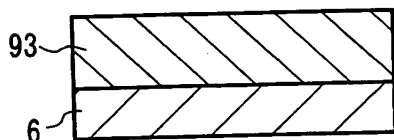


FIG. 11C
PRIOR ART

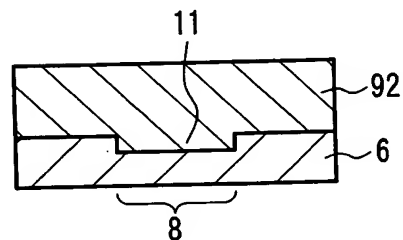
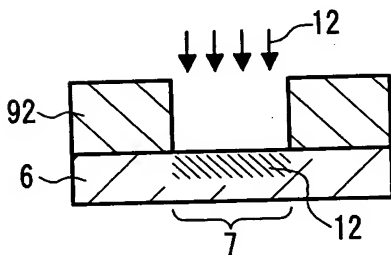


FIG. 11D
PRIOR ART

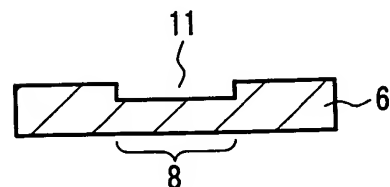
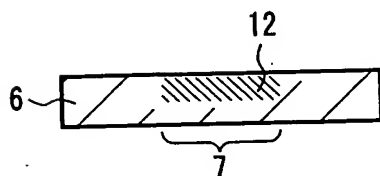


FIG. 12A
PRIOR ART

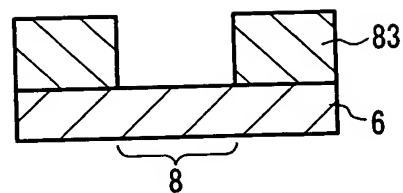
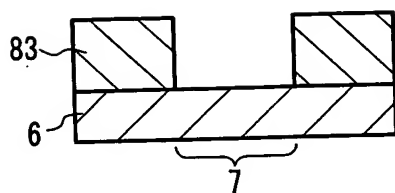


FIG. 12B
PRIOR ART

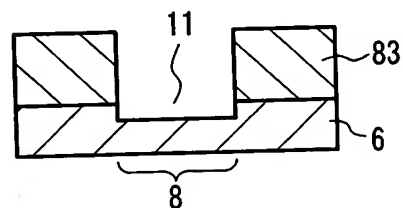
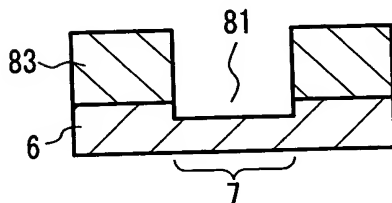


FIG. 12C
PRIOR ART

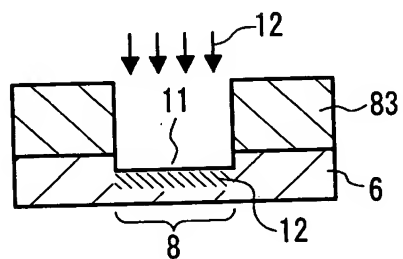
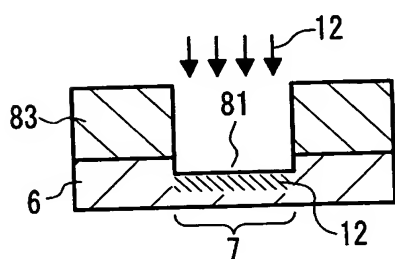


FIG. 12D
PRIOR ART

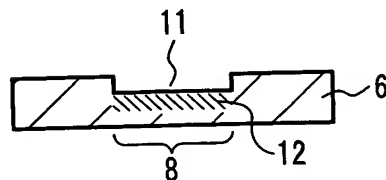
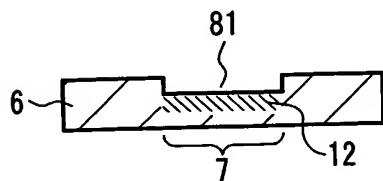


FIG. 13A
PRIOR ART

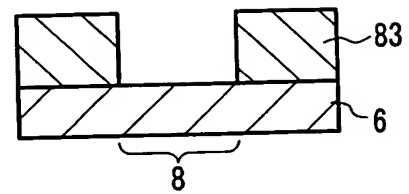
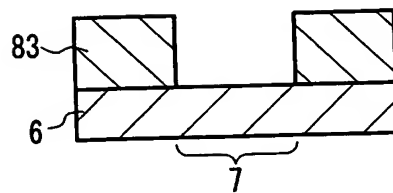


FIG. 13B
PRIOR ART

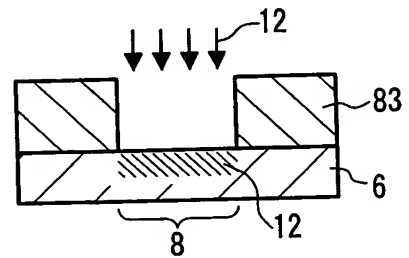
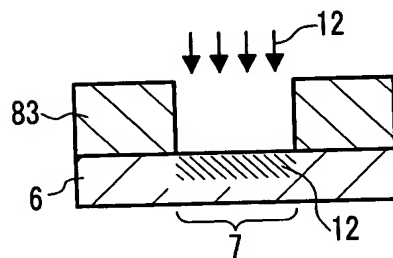


FIG. 13C
PRIOR ART

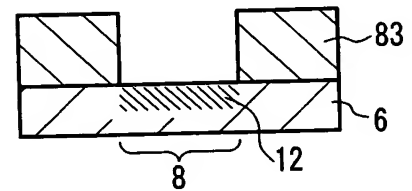
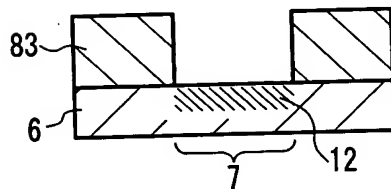


FIG. 13D
PRIOR ART

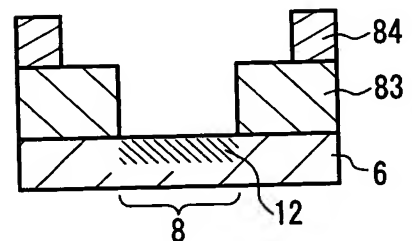
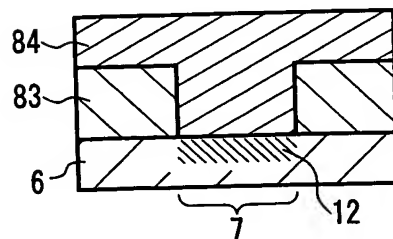


FIG. 14A
PRIOR ART

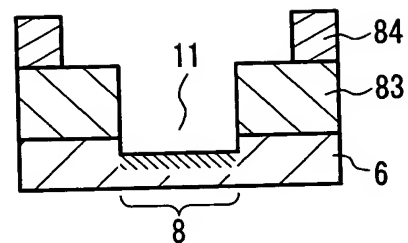
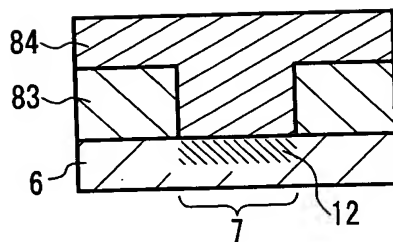


FIG. 14B
PRIOR ART

